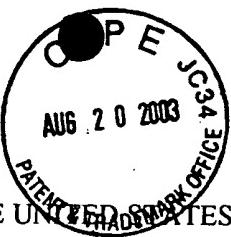


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of

Confirmation No. 7678

Kazuyuki NITTA et al.

Docket No. 2001_1703A

Serial No. 09/987,718

Group Art Unit 1756

Filed November 15, 2001

Examiner K. Sagar

METHOD FOR FORMING A HOLE-PATTERNED PHOTORESIST LAYER

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#5/EOT
(2m)

PETITION FOR EXTENSION OF TIME

Commissioner for Patents

P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of March 21, 2003.

The fee of \$410.00 is

submitted herewith.

to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

Small entity status of this application is established by a Small Entity Status Assertion which

is enclosed.

has been previously submitted.

Respectfully submitted,

Kazuyuki NITTA et al.

08/21/2003 GWORDDF1 00000037 09987718

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By Matthew Jacob
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August 20, 2003